

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants	: Sakae KOYATA et al.,	Group Art Unit	: Not yet assigned
Appl. No.	: Not yet assigned	Examiner	: Not yet assigned
Filed	: Concurrently herewith	Confirmation No.	: Not yet assigned
For	: METHOD FOR MANUFACTURING SINGLE-SIDE MIRROR SURFACE WAFER		

**AUTHORIZATION TO CHARGE DEPOSIT ACCOUNT**

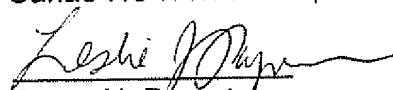
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Sir :

The undersigned hereby authorizes the U.S. Patent and Trademark Office to charge any fees necessary to maintain the pendency of the above-identified application, including any basic filing fees, application size fees, search fees, examination fees, extension of time fees, and claim fees, to Deposit Account No. 19-0089.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

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